

Notice of References Cited		Application/Control No. 10/540,925	Applicant(s)/Patent Under Reexamination, LEE ET AL.	
		Examiner Emmanuel Hailemariam	Art Unit 2629	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,380,923	04-2002	Fukumoto et al.	345/156
*	B	US-6,075,517	06-2000	Frid, Aleksandr	345/156
*	C	US-6,766,036	07-2004	Pryor, Timothy R.	382/103
*	D	US-6,088,017	07-2000	Tremblay et al.	345/156
*	E	US-6,261,247	07-2001	Ishikawa et al.	600/587
*	F	US-6,515,669	02-2003	Mohri, Koh	345/474
*	G	US-5,638,092	06-1997	Eng et al.	345/158
*	H	US-6,515,669	02-2003	Mohri, Koh	345/474
*	I	US-2003/0214481	11-2003	Xiong, Yongming	345/157
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.